

L Number	Hits	Search Text	DB	Time stamp
-	67	datum near platen	USPAT	2003/08/08 15:21
-	1	(datum near platen) and wafer	USPAT	2002/11/05 13:49
-	1873	((standard reference calibrat\$3) near wafer	USPAT	2002/11/05 13:49
-	0	((standard reference calibrat\$3) near wafer) near slice	USPAT	2002/11/05 13:50
-	0	((standard reference calibrat\$3) near wafer) near strip	USPAT	2002/11/05 13:50
-	4	((standard reference calibrat\$3) near wafer) near thin	USPAT	2002/11/05 13:50
-	201	(359/509).CCLS.	USPAT	2002/11/05 14:06
-	4	((359/509).CCLS.) and venturi	USPAT	2002/11/05 14:07
-	320	venturi and wafer	USPAT	2002/11/05 14:08
-	1	("6218320").PN.	USPAT	2003/03/07 15:44
-	1	("5503875").PN.	USPAT	2003/03/07 15:44
-	1	("5679165").PN.	USPAT	2003/03/07 15:45
-	1	("6495805").PN.	USPAT	2003/03/07 15:47
-	4	((("6218320").PN.) ((("5503875").PN.) ((("5679165").PN.) ((("6495805").PN.)	USPAT	2003/03/07 15:45
-	0	((("6218320").PN.) ((("5503875").PN.) ((("5679165").PN.) ((("6495805").PN.)) and (lens window)	USPAT	2003/03/07 15:45
-	32	((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.	USPAT	2003/03/07 15:49
-	12	((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.	USPAT	2003/03/07 15:49
-	44	((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) (((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.)	USPAT	2003/03/07 15:49

-	17	((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) (((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.)) and (lens window)	USPAT	2003/03/07 15:54
-	7	((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) (((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.)) and (lens window)) and valve	USPAT	2003/03/07 15:51
-	7	((((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) (((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.)) and (lens window)) and valve) and gas	USPAT	2003/03/07 15:51

	5	((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) (((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.)) and (lens)	USPAT	2003/03/07 15:54
	2	((((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) (((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.)) and (lens)) and valve	USPAT	2003/03/07 15:54
	2	(((((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) (((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.)) and (lens)) and valve)	USPAT	2003/03/07 15:54
	7908	deposition near chamber	USPAT; US-PGPUB	2003/03/27 13:00
	64	(deposition near chamber) same lens	USPAT; US-PGPUB	2003/03/27 13:05
	0	((deposition near chamber) same lens) and (datum near platen)	USPAT; US-PGPUB	2003/03/27 13:05
	0	(datum near platen) and (deposition near chamber)	USPAT; US-PGPUB	2003/03/27 13:05
	79	datum near platen	USPAT; US-PGPUB	2003/03/27 13:06
	13	(datum near platen) and (wafer semiconductor)	USPAT; US-PGPUB	2003/03/27 13:07

-	238	(deposition near chamber) and platen	USPAT; US-PGPUB	2003/03/27 13:07
-	30	((deposition near chamber) and platen) and lens	USPAT; US-PGPUB	2003/03/27 13:08
-	5	cdv and (lens same (housing chamber))	USPAT; US-PGPUB	2003/08/07 22:07
-	892	cvd and (lens same (housing chamber))	USPAT; US-PGPUB	2003/08/07 22:00
-	193	(cvd and (lens same (housing chamber))) and (inert and nitrogen)	USPAT; US-PGPUB	2003/08/07 22:07
-	0	((cvd and (lens same (housing chamber))) and (inert and nitrogen)) and venturi	USPAT; US-PGPUB	2003/08/07 22:00
-	0	(cvd and (lens same (housing chamber))) and venturi	USPAT; US-PGPUB	2003/08/07 22:00
-	191	cvd and venturi	USPAT; US-PGPUB	2003/08/07 22:01
-	77	(cvd and venturi) and (venturi same vacuum)	USPAT; US-PGPUB	2003/08/07 22:01
-	169	((cvd and (lens same (housing chamber))) and (inert and nitrogen)) and vacuum	USPAT; US-PGPUB	2003/08/07 22:01
-	246	((cvd and venturi) and (venturi same vacuum)) (((cvd and (lens same (housing chamber))) and (inert and nitrogen)) and vacuum)	USPAT; US-PGPUB	2003/08/07 22:02
-	48	(((cvd and venturi) and (venturi same vacuum)) (((cvd and (lens same (housing chamber))) and (inert and nitrogen)) and vacuum) and (nozzle and valve))	USPAT; US-PGPUB	2003/08/07 22:02
-	17	(((cvd and venturi) and (venturi same vacuum)) (((cvd and (lens same (housing chamber))) and (inert and nitrogen)) and vacuum) and (nozzle and valve)) and ((platen platform stage support) same (reference standard\$ datum))	USPAT; US-PGPUB	2003/08/07 22:09
-	6578	(semiconductor wafer) and (lens same (housing chamber))	USPAT; US-PGPUB	2003/08/07 22:07
-	516	(semiconductor wafer) and (lens same (housing chamber)) and (inert and nitrogen)	USPAT; US-PGPUB	2003/08/07 22:08
-	3	((semiconductor wafer) and (lens same (housing chamber))) and (inert and nitrogen) and venturi	USPAT; US-PGPUB	2003/08/07 22:08
-	211	((semiconductor wafer) and (lens same (housing chamber))) and (inert and nitrogen) and ((platen platform stage support) same (reference standard\$ datum))	USPAT; US-PGPUB	2003/08/07 22:09
-	42	(((semiconductor wafer) and (lens same (housing chamber))) and (inert and nitrogen) and ((platen platform stage support) same (reference standard\$ datum))) and (vacuum and nozzle)	USPAT; US-PGPUB	2003/08/07 22:09
-	35	((((semiconductor wafer) and (lens same (housing chamber))) and (inert and nitrogen) and ((platen platform stage support) same (reference standard\$ datum))) and (vacuum and nozzle)) and valve	USPAT; US-PGPUB	2003/08/07 22:09
-	6	5360980.URPN.	USPAT	2003/08/07 22:15
-	4	("3986023" "4752131" "5083865" "5153671").PN.	USPAT	2003/08/07 22:16
-	20	5083865.URPN.	USPAT	2003/08/07 22:18
-	212	(359/509).CCLS.	USPAT; US-PGPUB	2003/08/08 15:21
-	140	(250/431, 428).CCLS.	USPAT; US-PGPUB	2003/08/08 15:21
-	446	(356/36).CCLS.	USPAT; US-PGPUB	2003/08/08 15:21

-	400	(156/345.12,345.13,345.15).CCLS.	USPAT; US-PGPUB	2003/08/08 15:22
-	1196	((359/509).CCLS.) ((250/431,428).CCLS.) ((356/36).CCLS.)	USPAT; US-PGPUB	2003/08/10 20:38
-	8	((156/345.12,345.13,345.15).CCLS.) (((359/509).CCLS.) ((250/431,428).CCLS.) ((356/36).CCLS.) ((156/345.12,345.13,345.15).CCLS.)) and ((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))	USPAT; US-PGPUB	2003/08/08 15:24
-	5807	((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))	USPAT; US-PGPUB	2003/08/10 20:50
-	92	(((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate))	USPAT; US-PGPUB	2003/08/08 16:21
-	8	(((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate))) and (nitrogen and inert)	USPAT; US-PGPUB	2003/08/08 15:25
-	16	(((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and venturi	USPAT; US-PGPUB	2003/08/08 16:22
-	92	(((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate))	USPAT; US-PGPUB	2003/08/08 16:22
-	16	(((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and venturi	USPAT; US-PGPUB	2003/08/08 16:22
-	108	(((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate))) (((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and venturi)	USPAT; US-PGPUB	2003/08/08 16:23
-	92	((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate))) (((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and venturi)) and (inert nitrogen nozzle valve vacuum)	USPAT; US-PGPUB	2003/08/08 16:27
-	25	((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate))) (((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and venturi)) and ((inert nitrogen) and (nozzle valve vacuum))	USPAT; US-PGPUB	2003/08/08 16:24
-	67	((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate))) (((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and venturi)) and (inert nitrogen nozzle valve vacuum)) not (((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate))) ((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and venturi)) and ((inert nitrogen) and (nozzle valve vacuum)))	USPAT; US-PGPUB	2003/08/08 16:27
-	723	(cvp cmp polish\$3 etch\$3) and (dummy near (holder stage platform platen wafer))	USPAT; US-PGPUB	2003/08/10 20:41
-	1196	((359/509).CCLS.) ((250/431,428).CCLS.) ((356/36).CCLS.) (156/345.12,345.13,345.15).CCLS.)	USPAT; US-PGPUB	2003/08/10 20:38

-	6	((cvp cmp polish\$3 etch\$3) and (dummy near (holder stage platform platen wafer))) and (((359/509).CCLS.) ((250/431,428).CCLS.) ((356/36).CCLS.)) ((cvp cmp polish\$3 etch\$3) and (dummy near (holder stage platform platen wafer))) and (lens same (housing chamber))	USPAT; US-PGPUB	2003/08/10 20:38
-	23	((cvp cmp polish\$3 etch\$3) and (dummy near (holder stage platform platen wafer))) and (lens same (housing chamber))	USPAT; US-PGPUB	2003/08/10 20:42
-	23	((cvp cmp polish\$3 etch\$3) and (dummy near (holder stage platform platen wafer))) and (lens same (housing chamber)) not (((cvp cmp polish\$3 etch\$3) and (dummy near (holder stage platform platen wafer))) and (((359/509).CCLS.) ((250/431,428).CCLS.) ((356/36).CCLS.)) ((156/345.12,345.13,345.15).CCLS.)) ((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))	USPAT; US-PGPUB	2003/08/10 20:42
-	5807	((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))	USPAT; US-PGPUB	2003/08/10 20:51
-	672	((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck)) (((359/509).CCLS.) ((250/431,428).CCLS.) ((356/36).CCLS.)) ((156/345.12,345.13,345.15).CCLS.)) ((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck)))	USPAT; US-PGPUB	2003/08/10 20:52
-	1	((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck))) (((359/509).CCLS.) ((250/431,428).CCLS.) ((356/36).CCLS.)) ((156/345.12,345.13,345.15).CCLS.)) and (((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck)))	USPAT; US-PGPUB	2003/08/10 20:53
-	242	((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck))) (((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck))) and (nitrogen inert)	USPAT; US-PGPUB	2003/08/10 20:53
-	160	((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck))) and (nitrogen inert)) and (extract\$ exhaust)	USPAT; US-PGPUB	2003/08/10 20:53
-	56	((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck))) and (nitrogen inert)) and (extract\$ exhaust)) and nozzle	USPAT; US-PGPUB	2003/08/10 20:55
-	51	((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck))) and (nitrogen inert)) and (extract\$ exhaust)) and nozzle) and valve	USPAT; US-PGPUB	2003/08/10 20:55